I Mu	ımber	Hits	Search Text	DD	I m'
6	-111001	29	(351/45,51,165.ccls. and (dielectric or interference or asymmetr\$8 or	DB	Time stamp
"		29	antireflect\$4 or anti adj refelect\$4)) and (metal\$8 or conduct\$8)	USPAT;	2004/05/07 13:00
			antifericeus4 of anti-auj refereeus4)) and (metais8 of conducts8)	US-PGPUB;	
				ЕРО; ЛРО;	
ŀ				DERWENT;	
7		218	(251/41 44 47 40 150 162 166 177 1	IBM_TDB	
' ·		210	(351/41,44,47,49,159,163,166,177.ccls. and (dielectric or interference	USPAT;	2004/05/07 15:27
-			or asymmetr\$8 or antireflect\$4 or anti adj refelect\$4)) and (metal\$8 or	US-PGPUB;	
1			conduct\$8)	ЕРО; ЛРО;	
				DERWENT;	
		_	(/250/0 1 1/// 6	IBM_TDB	
. 8		5	((359/\$.ccls. and ((interference or dielectric or (asymmetr\$8 or anti) adj	USPAT;	2004/05/07 13:05
-			reflect\$4 or antireflect\$4) adj (filter or coating or mirror or layer\$4 or	US-PGPUB;	
1			multi or multilayer\$4))) and (metal\$8 or conductive or conducting)) and	ЕРО; ЛРО;	
	-		lens adj wafer	DERWENT;	0
				IBM_TDB	
9		408	(((lens and ((band or passband or interference or dielectric or	USPAT;	2004/05/07 13:08
		. *	(asymmetr\$8 or anti) adj reflect\$4 or antireflect\$4) adj (filter or coating	US-PGPUB;	
1		* .	or mirror or layer\$4 or multi or multilayer\$4)) and ((metal\$8 or	ЕРО; ЈРО;	•
1			conductive or conducting) adj layer) and (laminat\$4 or cement\$4)) and	DERWENT;	
			((dielectric or non adj conduct\$4 or nonconduct\$4 or oxide or	IBM_TDB	
1 .	•	•	"SiO.sub.2" or transparent or non adj absor\$5 or nonabsor\$5) adj layer))		
			and ((multi or multiple or plural\$3) adj layer\$3 or multilayer\$3)) and	1	
			(mark\$4 or logo or decorat\$4 or relief or pattern)		
11		107	359/\$ ccls. and ((lens and ((band or passband or interference or	USPAT;	2004/05/07 14:29
1			dielectric or (asymmetr\$8 or anti) adj reflect\$4 or antireflect\$4) adj	US-PGPUB;	ì
			(filter or coating or mirror or layer\$4 or multi or multilayer\$4)) and	ЕРО; ЛРО;	,
			((metal\$8 or conductive or conducting) adj layer) and (laminat\$4 or	DERWENT;	
			cement\$4)) and ((dielectric or non adj conduct\$4 or nonconduct\$4 or	IBM_TDB	
			oxide or "SiO.sub.2" or transparent or non adj absor\$5 or nonabsor\$5)	_	
	•		adj layer))		
12		. 25	351/\$.ccls. and (lens and ((band or passband or interference or dielectric	USPAT;	2004/05/07 14:35
			or (asymmetr\$8 or anti) adj reflect\$4 or antireflect\$4) near3 (filter or	US-PGPUB;	,
	1	1	.coat\$4 or mirror or layer\$4 or multi or multilayer\$4)) and ((metal\$8 or	ЕРО; ЛРО;	
			conductive or conducting) adj layer)) and (mark\$4 or logo or decorat\$4	DERWENT;	Y
İ		. *	or relief or pattern)	IBM_TDB	
13	ļ	43	359/\$.ccls. and ((lens and ((band or passband or interference or	USPAT;	2004/05/07 14:38
	- 1	-	dielectric or (asymmetr\$8 or anti) adj reflect\$4 or antireflect\$4) adj	US-PGPUB;	-
,			(filter or coating or mirror or layer\$4 or multi or multilayer\$4)) and	ЕРО; ЈРО;	*
,		•	(laminat\$4 or cement\$4 or lens adj wafer)) and (((dielectric or non adj	DERWENT,	
	, '		conduct\$4 or nonconduct\$4 or oxide or "SiO.sub.2" or transparent or	IBM_TDB	•
	. '		non adj absor\$5 or nonabsor\$5) adj layer)) with ((metal\$8 or conductive	* -	
,			or conducting) adj layer))	. *	
. 14		. 1	351/\$.ccls. and ((lens and ((band or passband or interference or	USPAT;	2004/05/07 14:36
1		. •	dielectric or (asymmetr\$8 or anti) adj reflect\$4 or antireflect\$4) adj	US-PGPUB;	
	ļ		(filter or coating or mirror or layer\$4 or multi or multilayer\$4)) and	EPO; JPO;	
1	,		(laminat\$4 or cement\$4 or lens adj wafer)) and (((dielectric or non adj	DERWENT;	
			conduct\$4 or nonconduct\$4 or oxide or "SiO.sub.2" or transparent or	IBM_TDB	*
			non adj absor\$5 or nonabsor\$5) adj layer)) with ((metal\$8 or conductive	<del>-</del>	
100		0	or conducting) adj layer))		
15	- 0	301	lens and ((band or passband or interference or dielectric or (asymmetr\$8	USPAT;	2004/05/07 14:47
1			or anti) adj reflect\$4 or antireflect\$4) adj (filter or coating or mirror or	US-PGPUB;	
	Į,		layer\$4 or multi or multilayer\$4)) and (laminat\$4 or cement\$4 or lens	EPO; JPO;	
		· ]	adj wafer) and ((dielectric or non adj conduct\$4 or nonconduct\$4 or	DERWENT;	X
			oxide or "SiO.sub.2" or transparent or non adj absor\$5 or nonabsor\$5)	IBM_TDB	·
	}		adj layer) with ((metal\$8 or conductive or conducting) adj layer)		,
16		352	351/163.ccls.	USPAT;	2004/05/07 15:31
B 0 30 V	4	(e)	manager souther than it is a subject of the contract of the co	US-PGPUB;	Consider a remaining
				EPO; JPO;	
				DERWENT;	
				IBM_TDB	•

20		59	359/585.ccls. and lens	I I I OD A D	I to a state of the state of th
		, ,	333/303.ccis. and icis	USPAT;	2004/05/07 16:28
}				US-PGPUB;	
			d v	ЕРО; ЛРО;	
				DERWENT,	1
				IBM TDB	
21		327	359/360.ccls.	USPAT;	2004/05/07 16:28
1				US-PGPUB;	
ļ				ЕРО; ЛРО;	
				DERWENT;	'
22	1	<b>70</b>	250/260	IBM_TDB	,
22 .	ļ	68	359/360.ccls. and lens	USPAT;	2004/05/07 16:28
Ì	*			US-PGPUB;	,
			,	ЕРО, ЛРО,	
		*		DERWENT;	·
Ļ				IBM TDB	

L Number	Hits	Search Text	DB	Time stamp
1	37	((351/41,44,47,49,159,163,166,177.ccls. and (dielectric or interference	USPAT;	2004/05/07 11:53
		or asymmetr\$8 or antireflect\$4 or anti adj refelect\$4)) and (metal\$8 or	US-PGPUB;	
		conduct\$8)) and plasma	ЕРО; ЛРО;	
			DERWENT;	
		,	IBM_TDB	
2	15	351/\$.ccls. and niobium	USPAT;	2004/05/07 11:56
			US-PGPUB;	W
	a .		ЕРО; ЛРО;	
			DERWENT;	
i _			IBM_TDB	
3	57	359/585.ccls. and niobium	USPAT;	2004/05/07 12:34
			US-PGPUB;	
		· · · · · · · · · · · · · · · · · · ·	ЕРО; ЛРО;	
			DERWENT;	,
			IBM TDB	